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Rih Data Sheet

CONFIRMATION NO. 8080

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SERIAL NUMB 10/615,062	FILING DATE 07/08/2003 RULE		C	CLASS 118	GROUP ART UNIT 1763		ATTORNEY DOCKET NO. 29926/39496		
APPLICANTS									
Hyug-Jin Kwon, Kyoungki-Do, KOREA, REPUBLIC OF;									
** CONTINUING DATA **********************************									
** FOREIGN APPLICATIONS ************************************									
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/02/2003									
Foreign Priority claimed 35 USC 119 (a-d) conditions			In 1	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 6		TOTA CLAII 13	MS	INDEPENDENT CLAIMS 3
ADDRESS 04743 MARSHALL, GERSTEIN & BORUN LLP 233 S. WACKER DRIVE, SUITE 6300 SEARS TOWER CHICAGO, IL 60606									
TITLE Batch type atomic layer deposition apparatus and in-situ cleaning method thereof									
	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:					All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time)			